



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/611,037
Applicant: : Kuthi, et al.
Filed: : July 6, 2000
Title: : METHOD FOR IMPLEMENTING A
SEMICONDUCTOR PROCESS CHAMBER
ELECTRODE

TC/A.U. : 1763
Examiner : Alejandro Mulero, L.

Atty. Docket No. : LAM1P077A
Date: : April 24, 2003

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Signed: _____

Neely Jo Weldy

Honorable Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

Applicants submit this paper in response to the Office Action dated January 24, 2003. The period for response extends to April 24, 2003. Please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Argument begins on page 8 of this paper.